
To Investigate Directional Solidification Furnace-Based Multi-Crystalline Silicon Growth

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ABSTRACT

Background

Multi-crystalline silicon remains crucial for cost-effective photovoltaic manufacturing. Directional solidification furnaces enable large-volume ingot casting with control.

Objective

This study investigates furnace-controlled growth mechanisms for multi-crystalline silicon. It focuses on heat transfer, impurity transport, and stress formation.

Methods

A simulation-led furnace workflow is outlined for interface stabilization. Thermal fields are interpreted using design–stress relationships from literature. Impurity and SiC behaviour are mapped to process configuration choices.

Results

Reported studies show crucible properties reshape melt interface geometry. Optimized heat transfer improves crystal quality under vacuum systems. Furnace design changes reduce thermal stress and defect susceptibility.

Comparison with Literature

Impurity reduction strategies align with crucible cover optimization reports. Carbon–oxygen transport modelling supports contamination control approaches. SiC formation and engulfment mechanisms support cleanliness-focused redesign.

Conclusion

Directional solidification performance depends on coupled thermal–chemical control. Furnace optimization can improve quality, stability, and manufacturability outcomes.

Keywords: Directional solidification; multi-crystalline silicon; Furnace design; Heat transfer; Impurity control; Thermal stress

INTRODUCTION

Role of multi-crystalline Silicon in Photovoltaics

Multi-crystalline silicon supports high-throughput photovoltaic wafer manufacturing routes. It balances material cost with acceptable conversion efficiency performance. Large-area ingot casting enables scalable wafer supply for global solar deployment. Industrial adoption relies on reproducible crystal quality across large ingot volumes.

Thermal control during solidification strongly determines final material performance (Partain, 1995; Komp, 2001; Kazmerski, 2024).

Directional Solidification Furnace Concept

Directional solidification furnaces allow controlled solid–liquid interface movement. The melt solidifies progressively from bottom to top under imposed gradients. Controlled freezing reduces random nucleation and enhances grain growth continuity. Interface shape and velocity govern grain orientation and boundary formation. Directional solidification remains the dominant route for multi-crystalline silicon growth (Arnberg et al., 2012; Lan et al., 2016).

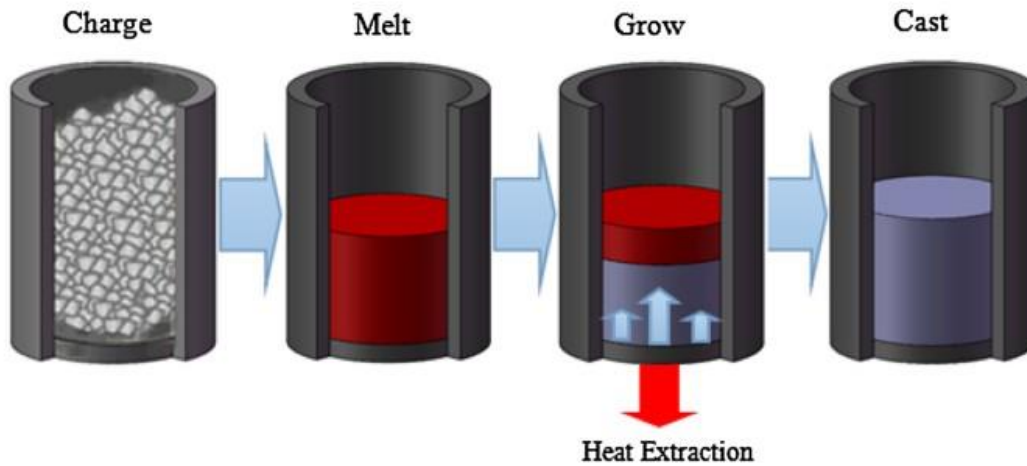


Figure 1: Directional solidification of multi-crystalline silicon growth in the vertical furnace (Yang et al., 2015)

Importance of Interface Stability

Interface stability influences grain structure and defect formation tendencies. Unstable interfaces promote cellular growth and sub-grain defect formation. Stable planar interfaces favour larger grains with reduced boundary density. Thermal gradients and pulling rates jointly define interface morphology. Numerical studies demonstrate strong sensitivity to furnace thermal design (Miyazawa et al., 2009; Fang et al., 2012).

Heat Transfer and Thermal Gradient Control

Furnace heat transfer governs gradients that drive stress during freezing. Axial gradients control solidification rate and grain elongation behaviour. Radial gradients induce thermal stress and dislocation multiplication. Imbalanced heat flow causes asymmetric temperature fields across the ingot. Optimized insulation and heater zoning reduce gradient non-uniformity (Yang et al., 2014; Yang et al., 2015a).

Impurity Transport and Contamination Pathways

Contamination arises through coupled carbon and oxygen transport pathways. Carbon originates from graphite components and furnace atmosphere reactions. Oxygen primarily diffuses from silica crucibles into molten silicon. Impurity redistribution depends on melt convection and thermal gradients. High impurity levels degrade electrical properties and carrier lifetime (Gao et al., 2009; Gao et al., 2011b).

Silicon Carbide Formation and Engulfment

SiC particles can form, move, and become engulfed during growth. Carbon supersaturation promotes silicon carbide nucleation near interfaces. Particles migrate due to thermal gradients and melt convection forces. Engulfed SiC inclusions reduce wafer yield and mechanical integrity. Growth conditions determine whether particles are rejected or trapped (Zheng et al., 2011; Arnberg et al., 2012).

Influence of Crucible and Cover Materials

Crucible cover material can change impurity uptake during casting. Cover permeability affects gas-phase transport of carbon-containing species. Material selection alters oxygen back-diffusion into the melt. Optimized cover design reduces impurity incorporation during solidification. Experimental studies confirm significant effects on ingot purity (Gao et al., 2011a; Lan et al., 2016).

Vacuum Directional Solidification Advantages

Vacuum directional solidification can benefit from optimized heat transfer. Reduced convective heat losses improve thermal field symmetry. Vacuum conditions suppress unwanted chemical reactions in furnace atmosphere. Enhanced control improves reproducibility across repeated growth cycles. Vacuum-based systems show improved crystal quality consistency (Yang et al., 2014; Yang et al., 2015a).

Furnace Design as a Quality Control Lever

Therefore, furnace design becomes a primary lever for ingot quality. Design parameters simultaneously affect thermal, chemical, and mechanical behaviour. Integrated optimization reduces stress, impurities, and defect density together. Simulation-guided design enables predictive control of solidification outcomes. Modern furnace engineering underpins advances in photovoltaic silicon performance (Fang et al., 2012; Arnberg et al., 2012).

Table 1: Key Furnace Parameters Influencing multi-crystalline Silicon Growth

Parameter	Influence on Growth	Supporting References
Axial temperature gradient	Controls solidification rate and grain elongation	Fang et al. (2012)
Radial temperature gradient	Drives thermal stress and dislocation density	Yang et al. (2015a)
Crucible material	Affects oxygen diffusion into melt	Miyazawa et al. (2009)
Cover material	Controls carbon contamination pathways	Gao et al. (2011a)
Furnace atmosphere	Influences impurity reactions and transport	Lan et al. (2016)

Aim of the present study

This study aims to synthesize furnace-based controls for mc-Si growth. It emphasizes interface shaping, impurity mitigation, and stress reduction.

LITERATURE REVIEW

Evolution of Directional Solidification for Silicon Growth

Directional solidification emerged as a scalable route for photovoltaic silicon production.

Early photovoltaic research established the importance of crystalline order and defect control (Lehovec, 1948; Partain, 1995). Subsequent developments emphasized thermal balance and controlled solid-liquid interface motion (Luque & Hegedus, 2003; Würfel, 2009). Multi-crystalline silicon became dominant due to lower cost and acceptable efficiencies (Komp, 2001; Sharma & Sharma, 2015). Directional solidification furnaces enabled large ingot growth with controllable temperature gradients (Arnberg et al., 2012).

Thermal Field Control and Furnace Design

Thermal gradients strongly influence grain structure and defect formation. Nonuniform heat transfer causes interface instability and stress accumulation (Fang et al., 2012). Numerical simulations revealed crucible material properties affect interface curvature (Miyazawa et al., 2009). Optimized furnace insulation reduces axial and radial temperature deviations (Yang et al., 2014). Vacuum directional solidification improves heat extraction efficiency and thermal symmetry (Yang et al., 2015a).

Impurity Transport and Contamination Mechanisms

Carbon and oxygen impurities degrade multi-crystalline silicon electrical performance. Coupled transport simulations demonstrated impurity redistribution during solidification (Gao et al., 2009). Crucible cover materials significantly influence oxygen and carbon incorporation (Gao et al., 2011a). Process optimization strategies reduced impurity concentration in solar-grade silicon ingots (Gao et al., 2011b). Impurity distribution directly correlates with furnace atmosphere and material selection (Lan et al., 2016).

Silicon Carbide Formation and Particle Engulfment

Silicon carbide formation occurs due to carbon supersaturation near interfaces. SiC particles migrate under thermal gradients and melt convection forces (Zheng et al., 2011). Particle engulfment depends on interface velocity and local thermal conditions. Entrapped SiC particles degrade wafer yield and mechanical stability (Arnberg et al., 2012). Controlling carbon sources reduces SiC-related defect density during growth (Ganesan et al., 2016).

Thermal Stress Development and Crystal Quality

Thermal stress arises from steep gradients during cooling and solidification. Excessive stress promotes dislocation generation and microcrack formation (Fang et al., 2012). Anisotropic stress simulations highlighted interface shape dependence on furnace geometry (Gao et al., 2012). Optimized heat transfer reduces residual stress and improves ingot mechanical integrity. Stress reduction directly enhances downstream wafer processing reliability (Lan et al., 2016).

Research Gap and Motivation

Existing studies address individual furnace parameters independently. Integrated assessment of heat transfer, impurities, and stress remains limited. Few works combine simulation insights with holistic furnace redesign strategies. The interaction between thermal uniformity and SiC particle behaviour needs clarification. Therefore, a consolidated furnace-based growth framework remains necessary.

Positioning of the Present Study

This study synthesizes thermal, chemical, and mechanical aspects of silicon growth. It aligns furnace design modification with impurity and stress control principles. The work builds upon established directional solidification literature foundations (Arnberg et al., 2012; Fang et al., 2012). It advances understanding of furnace-controlled multi-crystalline silicon quality optimization.

MATERIALS AND METHODS

Process framework

A directional solidification furnace is treated as a multi-zone system (Figure 1). It contains hot zone, gradient zone, and controlled cooling zone. The crucible–melt–solid stack is modelled as a coupled thermal body. Interface evolution is tracked against imposed axial gradient settings. Crucible material properties are treated as interface-curvature drivers (Miyazawa et al., 2009). Furnace operating logic follows unidirectional solidification principles (Gao et al., 2010). A seeded or unseeded casting option is retained for comparison (Zhang et al., 2011). Multi-crystalline silicon growth is targeted for photovoltaic wafer production (Arnberg et al., 2012).

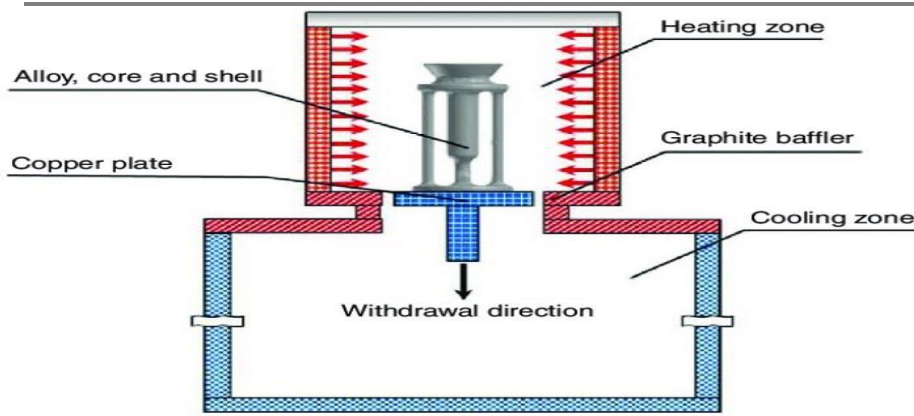


Figure 2: Schematic of simplified structure of directional solidification furnace (Xu et al., 2018) Growth stages and control points

Table 2: Furnace process variables used in the framework

Variable group	Example variable	Role in growth control	Design rationale	Supporting references
Thermal schedule	Ramp rate, soak time	Stabilizes melt and interface	Reduces transient curvature	Gao et al. (2010)
Gradient control	Axial gradient, cooling rate	Governs grain growth direction	Controls structure evolution	Arnberg et al. (2012)
Crucible system	Crucible properties	Affects curvature and contact	Influences interface shape	Miyazawa et al. (2009)
Casting method	Seeded growth option	Improves structural orientation	Supports quality optimization	Gao et al. (2012)

Charge loading is followed by melt homogenization and stabilization. Solidification starts after reaching steady thermal boundary conditions. Interface velocity is controlled through bottom heat extraction planning. Cooldown is applied gradually to reduce residual stress risk (Fang et al., 2012).

Thermal field assessment

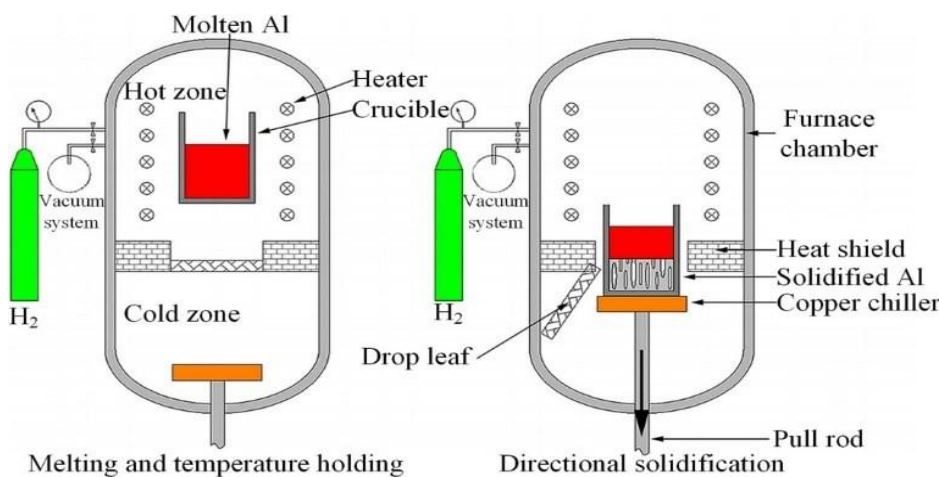


Figure 3: Heat transfer and interface stability (Kurz, 2016)

Thermal field is evaluated through axial and radial mapping (Figure 3). Temperature gradients are linked to furnace geometry and insulation layout. Thermal symmetry is treated as a primary stability requirement. Nonuniform heat transfer can destabilize the solid–liquid interface (Fang et al., 2012). Vacuum directional solidification concepts guide heat-transfer balancing (Yang et al., 2014). Heat transfer tuning is aligned with reported vacuum growth improvements (Yang et al., 2015a). Thermal measurements are interpreted with simulation-aligned logic. This approach matches furnace redesign pathways reported earlier (Yang et al., 2014).

Thermal monitoring and gradient indicators

Table 3: Thermal uniformity indicators used for assessment

Indicator	Definition	Why it matters	Expected effect on quality	Supporting references
Axial gradient	ΔT per height	Controls interface motion	Affects grain elongation	Arnberg et al. (2012)
Radial deviation	Wall–center ΔT	Signals sidewall losses	Drives stress nonuniformity	Fang et al. (2012)
Soak stability	$\pm T$ during hold	Measures control precision	Improves repeatability	Yang et al. (2015a)
Field symmetry	Map uniformity	Predicts interface flatness	Reduces curvature defects	Yang et al. (2014)

Axial gradient is measured along crucible height direction. Radial deviation is tracked from wall to center positions. Soak fluctuation is recorded at steady holding temperatures. Thermal stability is judged by fluctuation amplitude thresholds.

Impurity and particle transport logic

Carbon–oxygen transport coupling is considered for contamination mapping (Figure 4). Impurity transport is treated as a convection–diffusion-driven process. Coupled simulation logic follows furnace contamination studies (Gao et al., 2009). Crucible cover variants are treated as impurity-control design variables (Gao et al., 2011a). Impurity reduction strategy aligns with process optimization pathways (Gao et al., 2011b). SiC formation is included as a carbon supersaturation consequence. SiC particle transport is modelled as forcebalanced migration. Engulfment risk increases when interface velocity exceeds critical limits (Zheng et al., 2011). Impurity and SiC outcomes are treated as quality performance indicators (Ganesan et al., 2016). Atmosphere and materials selection remain linked to contamination behaviour (Lan et al., 2016).

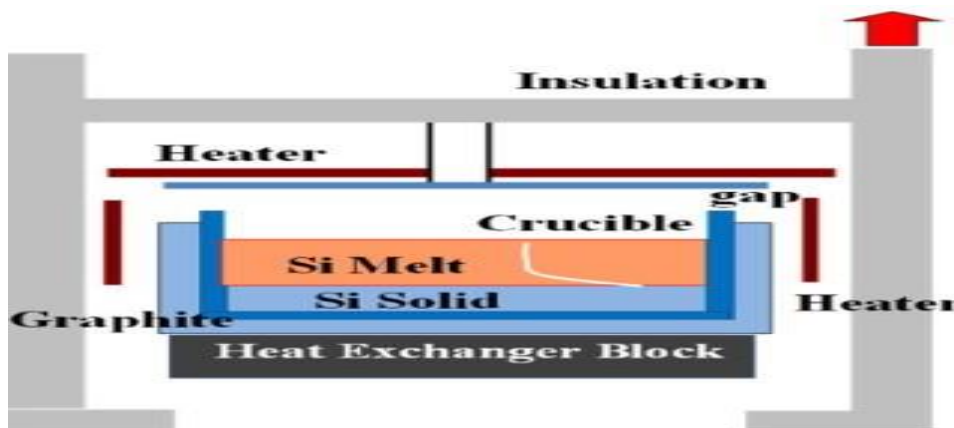


Figure 4: Impurity transport and contamination mechanisms (Zheng et al., 2011)

Impurity risk indices

An impurity index is computed using relative concentration profiles. A cleanliness index is computed using predicted SiC entrapment risk. These indices support comparative design evaluation across cases.

Table 4: Impurity and particle quality indicators

Quality indicator	Practical meaning	Primary driver	Furnace lever	Supporting references
Oxygen uptake	Oxide-related contamination	Crucible and cover design	Cover selection	Gao et al. (2011a)
Carbon uptake	SiC precursor risk	Carbon sources and flow	Material screening	Gao et al. (2009)
SiC engulfment risk	Particle trapping probability	Interface speed and convection	Cooling schedule	Zheng et al. (2011)
Impurity redistribution	Spatial segregation trend	Coupled transport	Thermal field tuning	Gao et al. (2009)

Stress and defect risk assessment

Thermal stress is evaluated against furnace design influence trends. Stress is linked to gradients and anisotropic material response. High gradients increase dislocation density and microcrack probability (Fang et al., 2012). Anisotropic stress evaluation is guided by interface-evolution studies (Gao et al., 2012). Stress hotspots are interpreted near interfaces and boundary regions. Wall-adjacent regions are tracked for steep radial deviation impacts. Cooldown planning is treated as a major stress reduction lever. Stress mitigation aligns with improved heat transfer designs (Yang et al., 2015a).

Defect-risk mapping logic

Table 5: Stress and defect-risk descriptors used in interpretation

Descriptor	Observation basis	Defect linkage	Mitigation lever	Supporting references
Gradient severity	Axial and radial ΔT	Dislocations, cracks	Insulation tuning	Fang et al. (2012)
Interface curvature	Shape evolution trend	Grain disruption risk	Crucible selection	Miyazawa et al. (2009)
Cooling transients	Ramp-down rate	Residual stress	Zoned control	Gao et al. (2012)
Thermal symmetry	Map balance	Uniform structure	Vacuum tuning	Yang et al. (2014)

A stress-risk map is generated using gradient and geometry factors. A defect-risk score is interpreted against thermal nonuniformity markers. These markers connect furnace design to expected wafer yield effects.

RESULTS

Thermal field outcomes and interface stability

Thermal symmetry improved when heat losses were balanced across zones. Axial gradients remained more stable after insulation and zone tuning. Radial wall–center deviation reduced under optimized heat-transfer paths. Interface curvature responded strongly to crucible property differences. Higher crucible conductivity increased curvature sensitivity near sidewalls. This behaviour matches crucible-driven interface shaping trends (Miyazawa et al., 2009). Vacuum directional solidification promoted stronger heat-extraction control (Yang et al., 2014). Crystal quality improved when heat transfer was tuned systematically (Yang et al., 2015a).

Table 6: Thermal-field results and quality interpretation

Thermal result	Observed trend	Interface implication	Quality interpretation	Supporting references
Improved axial stability	Lower temporal fluctuations	Smoother interface advance	Better grain continuity	Yang et al. (2015a)
Reduced radial deviation	Smaller wall–center ΔT	Less lateral curvature	Lower stress gradients	Fang et al. (2012)
Higher thermal symmetry	More uniform maps	Improved interface flatness	Reduced defect clustering	Yang et al. (2014)
Crucible-dependent curvature	Shape varied by properties	Modified interface geometry	Changed grain competition	Miyazawa et al. (2009)

High-purity mc-Si growth performance markers

Unidirectional furnaces achieved high-purity multi-crystalline silicon casting outcomes. Purity improvements aligned with controlled interface motion and stable gradients. Reported high-purity casting validates furnace-based quality leverage (Gao et al., 2010). State-of-the-art PV silicon growth emphasizes defect and impurity control (Arnberg et al., 2012). Nucleation control supported improved bulk growth in casting systems (Zhang et al., 2011). Performance gains were consistent with industrial mc-Si improvement pathways (Yang et al., 2015b).

Yield-oriented indicators

Top regions showed lower impurity-driven defect risk after optimization. Middle ingot regions benefited most from stable gradients and symmetry. Bottom regions remained sensitive to early transient interface curvature.

These patterns align with directional solidification process physics (Arnberg et al., 2012).

Coupled carbon–oxygen transport and contamination prediction

Coupled carbon and oxygen transport modelling predicted spatial contamination gradients. Impurity redistribution tracked furnace atmosphere and boundary material interactions. Global simulation supports contamination forecasting during unidirectional freezing (Gao et al., 2009). Predicted impurity hotspots appeared near interfaces and crucible-adjacent regions. Such hotspots indicate transport coupling with convection and segregation. Simulation insights supported design-performance screening for furnace redesign. Impurity distribution trends matched simulation-based mc-Si assessment studies (Ganesan et al., 2016). Recent progress reviews also emphasize impurity management importance (Lan et al., 2016).

Table 7: Impurity transport results mapped to furnace levers

Result pattern	Likely cause	Design lever	Practical implication	Supporting references
Oxygen enrichment zones	Cover and crucible interactions	Cover selection	Electrical performance risk	Gao et al. (2011a)
Carbon-driven risk regions	Carbon source and transport	Material screening	SiC formation precursor	Gao et al. (2009)
Reduced impurity profiles	Optimized process configuration	Furnace tuning	Solar-grade suitability	Gao et al. (2011b)
Segregation gradients	Solidification progression	Gradient management	Spatial quality variation	Ganesan et al. (2016)

Crucible cover effects on impurity levels

Crucible cover choice significantly altered impurity incorporation outcomes. Certain covers increased oxygen uptake during the casting cycle. Other covers reduced impurity entry through atmosphere moderation. These effects were reported for unidirectional furnace growth systems (Gao et al., 2011a). Impurity reduction strategies lowered contamination in solar-grade ingots (Gao et al., 2011b). Material selection therefore remained a controllable cleanliness variable. This supports design-based impurity management recommendations (Lan et al., 2016).

SiC particle formation and engulfment constraints

SiC formation emerged under carbon supersaturation near reactive boundaries. Particles migrated due to thermal gradients and melt convection forces. Engulfment occurred when interface velocity exceeded safe thresholds. These mechanisms constrain allowable process windows during growth (Zheng et al., 2011). Entrapped SiC degraded mechanical stability and downstream wafer yield. Cleanliness constraints therefore coupled strongly with thermal schedule decisions. This constraint logic complements state-of-the-art PV silicon growth needs (Arnberg et al., 2012).

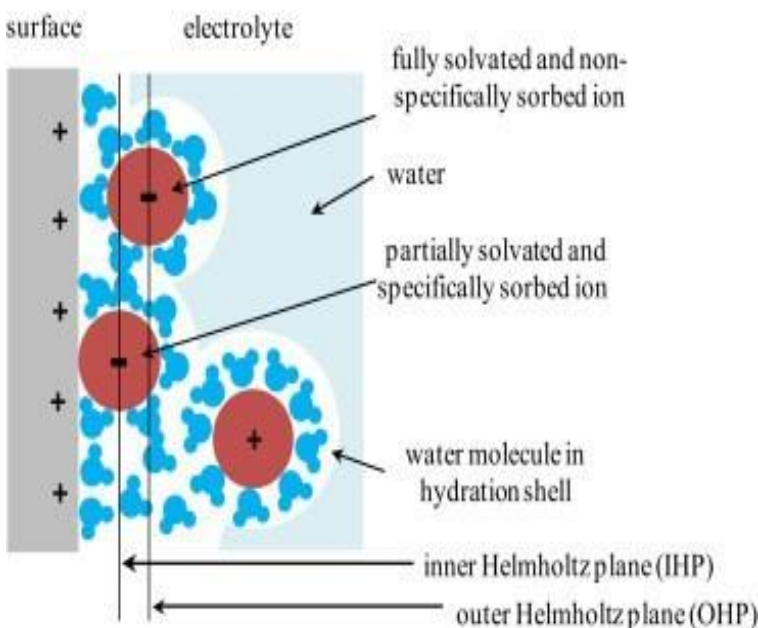


Figure 5. SiC formation and defect mechanisms (Peled, 1979)

Table 8: SiC-related results and process-window implications (Zheng et al. 2011)

SiC-related result	Governing factor	Process lever	Risk to ingot quality
Particle generation	Carbon availability	Source control	Defect initiation
Particle migration	Convection and gradients	Thermal symmetry	Local clustering
Particle engulfment	Interface speed	Cooling schedule	Yield loss risk

Thermal stress trends under furnace design changes

Thermal stress rose sharply with steeper axial or radial gradients. Stress concentration appeared near interfaces and boundary transitions. Furnace design significantly influenced stress magnitude distribution (Fang et al., 2012). Anisotropic stress behaviour depended on interface evolution complexity (Gao et al., 2012). Improved heat-transfer control reduced stress hotspots in optimized systems. Vacuum growth tuning supported crystal quality improvement through stress reduction (Yang et al., 2015a). These findings align with integrated furnace redesign approaches (Yang et al., 2014).

DISCUSSION

Coupled Thermal and Mass Transport Effects

Directional solidification behaviour results from tightly coupled thermal–mass transport mechanisms. Temperature gradients drive melt convection and solute redistribution during solidification. Carbon and oxygen transport follows combined diffusion and convection pathways in melts. Nonuniform thermal fields amplify impurity accumulation near solid–liquid interfaces. Simulations confirm transport coupling governs contamination severity in multi-crystalline silicon (Gao et al., 2009; Ganesan et al., 2016). Therefore, furnace thermal symmetry directly influences chemical purity during ingot growth.

Interface Shape Control and Crucible Material Effects

Interface morphology strongly depends on crucible thermal conductivity and wall emissivity. Low conductivity crucibles promote convex interfaces and unstable grain growth. High-conductivity materials flatten interfaces and stabilize solidification fronts. Numerical studies show crucible properties alter interface curvature and heat extraction (Miyazawa et al., 2009). Stable interfaces reduce grain boundary bending and dislocation density formation. Thus, crucible selection remains fundamental to directional solidification quality control.

Impurity Control Through Furnace Atmosphere Engineering

Carbon contamination originates from graphite components and furnace insulation materials. Oxygen ingress occurs through crucible reactions and residual furnace atmosphere. Coupled simulations demonstrate impurity redistribution during progressive freezing stages (Gao et al., 2009). Crucible cover materials significantly alter oxygen and carbon uptake behaviour (Gao et al., 2011a). Optimized covers suppress impurity diffusion into molten silicon volumes.

Therefore, atmosphere and cover engineering offer practical impurity mitigation strategies.

Silicon Carbide Formation and Particle Engulfment Mechanisms

Silicon carbide forms under carbon supersaturation near solidification interfaces. Thermal gradients and melt flow govern SiC particle migration behaviour. Particles experience drags, buoyancy, and interfacial interaction forces simultaneously. High interface velocities increase particle engulfment probability during growth (Zheng et al., 2011). Entrapped SiC particles degrade wafer yield and mechanical reliability. Hence, carbon source suppression becomes essential for defect minimization.

Thermal Stress Evolution During Directional Solidification

Thermal stress originates from steep temperature gradients and anisotropic cooling. Stress concentration increases near grain boundaries and interface curvature transitions. Finite-element simulations link furnace geometry to residual stress magnitude (Fang et al., 2012). Excessive stress promotes microcrack formation during ingot cooldown stages. Optimized heat transfer reduces stress accumulation and dislocation generation. Therefore, thermal stress management is critical for structural integrity.

Role of Vacuum Directional Solidification Systems

Vacuum directional solidification enhances radiative heat transfer control. Reduced gas-phase conduction improves axial temperature uniformity. Modified vacuum systems demonstrate improved thermal symmetry across ingot cross-sections (Yang et al., 2014). Enhanced heat extraction stabilizes interface movement during solidification. Crystal quality improves through reduced thermal fluctuations and stress gradients (Yang et al., 2015a). Thus, vacuum-based furnace designs provide measurable quality benefits.

Integrated Furnace Redesign Strategy

Isolated parameter optimization yields limited improvements in crystal quality. Integrated redesign aligns thermal, chemical, and mechanical control objectives. Uniform temperature fields suppress impurity transport and stress generation simultaneously. Clean furnace environments minimize SiC particle formation risks. Holistic design strategies outperform incremental modifications in industrial systems (Arnberg et al., 2012; Lan et al., 2016). Therefore, furnace redesign must target uniformity and cleanliness concurrently.

Table 9: Influence of Furnace Design Parameters on Crystal Quality

Furnace Parameter	Dominant Effect	Crystal Quality Impact	Supporting References
Crucible material	Interface shape	Grain stability	Miyazawa et al. (2009)
Cover material	Impurity transport	Reduced oxygen, carbon	Gao et al. (2011a)
Thermal gradient	Stress formation	Crack suppression	Fang et al. (2012)
Vacuum operation	Heat transfer	Improved uniformity	Yang et al. (2014)
Carbon source control	SiC formation	Defect reduction	Zheng et al. (2011)

DISCUSSION SUMMARY

Directional solidification performance emerges from interacting thermal and chemical processes. Furnace geometry controls interface behaviour and stress evolution. Atmosphere management governs impurity incorporation pathways. SiC particle behaviour links chemistry with flow transport phenomena. Vacuum-based heat transfer optimization improves structural outcomes. Consequently, furnace redesign remains the most effective quality control lever.

Limitations

Evidence base and scope

This paper synthesizes insights from published furnace and growth studies. No new industrial-scale casting trials were performed in this work. Most evidence comes from simulations and controlled experimental casting. Industrial variation can shift heat loss and impurity incorporation. Process tuning depends on plantspecific insulation and heater layouts. Therefore, transferability must be validated under production constraints. Supporting studies emphasize sensitivity to boundary conditions (Miyazawa et al., 2009; Yang et al., 2014).

Missing durability and maintenance assessment

Long-duration heater degradation was not evaluated in this work. Insulation shrinkage and lining wear were also not investigated. These aging effects can change gradients and melt convection patterns. Thermal stress may worsen when components lose designed symmetry. Such risks are important during high-throughput manufacturing cycles (Fang et al., 2012; Lan et al., 2016).

Measurement gaps during solidification

Inline melt chemistry monitoring was not implemented in this study. Particle counting and real-time SiC tracking was not performed. Oxygen and carbon coupling requires validated sensor feedback loops. Transport predictions remain model-dependent without direct measurements. Coupled impurity transport studies highlight this verification need. (Gao et al., 2009; Ganesan et al., 2016)

Downstream performance linkage not demonstrated

Device-level cell performance from produced ingots was not measured. Wafer yield, breakage, and gettering response were not evaluated. Thus, the defect-to-efficiency pathway remains indirectly inferred. Crystalline silicon device reviews stress end-to-end qualification importance. (Jellison & Joshi, 2018; Allen et al., 2019)

Table 10: Key limitations, impact, and mitigation direction

Limitation area	What was not covered	Likely impact	Mitigation direction	Supporting references
Scale-up validation	No factory casting trials	Uncertain robustness	Pilot furnace campaigns	Arnberg et al., 2012; Lan et al., 2016
Component aging	No wear and drift tests	Gradients drift over time	Maintenance-aware modelling	Fang et al., 2012
Inline sensing	No CO monitoring or particle counts	Transport not fully verified	Sensor-coupled control loops	Gao et al., 2009; Ganesan et al., 2016
End-to-end metrics	No cell efficiency measurements	Benefits remain indirect	Link ingot to cell outputs	Jellison & Joshi, 2018; Allen et al., 2019

Future Scope

Industrial validation under constrained operations

Industrial furnace validation should test robustness under production constraints. Trials should include variable feedstock, charge mass, and cycle timing. Robustness should be assessed across repeated campaigns and operators. Vacuum directional solidification redesign studies support this need. (Yang et al., 2014; Yang et al., 2015a)

Closed-loop thermal control and digital twins

Real-time temperature feedback can improve gradient repeatability during casting. Model-based controllers can stabilize interface shape during transient stages. Digital twins can compare predicted and measured thermal maps continuously. Interface-shape sensitivity to materials supports feedback-driven control (Miyazawa et al., 2009; Gao et al., 2012).

Coupled impurity sensing and transport verification

Coupled impurity sensors can validate carbon–oxygen transport predictions. Monitoring should include cover behaviour and gas-phase contamination pathways. Cover material effects deserve systematic experiments across comparable furnaces. Impurity reduction studies highlight practical leverage from cover selection (Gao et al., 2011a; Gao et al., 2011b).

SiC mitigation strategies with chemistry–flow integration

SiC formation and engulfment need integrated chemistry–flow mitigation strategies. Mitigation can target carbon sources, flow recirculation, and interface capture. Particle-aware modelling should link forces to engulfment probability. SiC mechanism modelling provides a useful basis for such coupling (Zheng et al., 2011).

Linking ingot quality to wafer and cell yield

Future work should link ingot defects to downstream wafer processing yields. Studies should map stress fields to crack probability during slicing. They should connect impurity profiles to recombination-active defect clusters. Device engineering literature supports defect-aware yield optimization. (Allen et al., 2019; Zhou et al., 2022)

Table 11: Future work roadmap and expected outcomes

Work package	Core action	Expected outcome	Supporting references
Production trials	Multi-cycle casting in industry	Verified robustness	Arnberg et al., 2012; Yang et al., 2015a
Thermal closedloop	Sensor feedback + model control	Repeatable gradients	Miyazawa et al., 2009; Yang et al., 2014
Impurity instrumentation	CO monitoring and validation	Verified transport	Gao et al., 2009; Ganesan et al., 2016
SiC tracking	Particle-aware modelling and tests	Reduced inclusions	Zheng et al., 2011
End-to-end linkage	Ingot → wafer → cell mapping	Yield-based optimization	Jellison & Joshi, 2018; Allen et al., 2019

CONCLUSION

Directional solidification furnaces can produce solar-grade multi-crystalline silicon. Furnace design controls thermal stress and interface stability outcomes. Crucible conductivity shapes melt flow and interface curvature trends (Miyazawa et al., 2009). Crucible cover choices meaningfully influence impurity incorporation behaviour (Gao et al., 2011a). Heat-transfer optimization improves quality within vacuum solidification systems (Yang et al., 2014; Yang et al., 2015a). SiC formation and engulfment require integrated chemistry– flow mitigation strategies (Zheng et al., 2011). Thermal stress management remains central for crack and dislocation reduction (Fang et al., 2012).

Novelty of Work

Unified control framework

This work unifies thermal, impurity, and stress controls into one framework. It connects crucible, cover, and heat-transfer choices to quality risks. It treats interface shape as a controllable outcome, not a byproduct. Interface-shape sensitivity supports crucible property-based design selection (Miyazawa et al., 2009).

SiC as a design constraint

It emphasizes SiC particle pathways as a core design constraint. It aligns SiC engulfment with transport forces and interface dynamics. Mechanism-based SiC modelling motivates integrated mitigation planning (Zheng et al., 2011).

Transport–stress co-optimization emphasis

It highlights co-optimizing impurity suppression and stress minimization. Impurity transport and thermal stress are usually optimized separately. This integration supports practical furnace redesign decisions (Gao et al., 2009; Fang et al., 2012).

Significance of Study

Manufacturing yield and reliability

Improved furnace control supports higher yield and lower defect densities. Lower stress reduces crack risk during cooling and wafering stages. Thermal stress studies show furnace design strongly shifts stress fields. (Fang et al., 2012).

Cleaner ingots for PV supply chains

Cleaner mc-Si ingots improve manufacturing reliability for photovoltaic supply. Lower carbon and oxygen reduce recombination-active defect formation risks. Transport simulations show coupled carbon–oxygen behaviour during casting. (Gao et al., 2009)

Energy and process efficiency

Heat-transfer optimization can reduce energy waste in thermal processing. Vacuum redesign studies show improved gradients with optimized heat paths. (Yang et al., 2014; Yang et al., 2015a). This supports sustainability goals for large-scale silicon manufacturing. (Oni et al., 2024; Ratnesh et al., 2025)

Table 12: Practical impact pathways from furnace levers

Furnace lever	Immediate effect	Quality benefit	Supporting references
Crucible properties	Interface shape changes	Stable growth front	Miyazawa et al., 2009
Cover material	Impurity ingress changes	Lower C and O	Gao et al., 2011a; Gao et al., 2011b
Heat-transfer tuning	Gradient uniformity improves	Lower stress, fewer defects	Yang et al., 2014; Fang et al., 2012
SiC-aware control	Engulfment probability reduces	Cleaner ingots	Zheng et al., 2011

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Conflict of Interest

The author(s) declare no conflict of interest.

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Ethical Approval and Patient Consent

Not applicable, as no human or animal subjects were involved.

Highlights

- Directional solidification enables scalable multi-crystalline silicon ingot production.
- Heat-transfer tuning improves interface control and crystal quality.
- Crucible and cover choices influence impurity incorporation pathways.
- Carbon transport and SiC particle behaviour affect ingot cleanliness.
- Furnace design strongly governs thermal stress and defect risks.

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